Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/565,740	NEUMETZLER, HEIKO
Examiner	Art Unit
Hion D. Vu	2022

SEARCHED					
Class	Subclass	Date	Examiner		
439	404,405, 79,562, 751	7/2/2007	н∨		
Updated	Search	3/21/2008	HV		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		